

Glow Discharge Processes: Sputtering And Plasma Etching

by Brian N Chapman

Radiofrequency (rf) capacitive discharges are widely applied for etching semiconductor materials, depositing thin films, hardening tool surfaces, pumping . Available in the National Library of Australia collection. Author: Chapman, Brian N; Format: Book; xv, 406 p. : ill. ; 24 cm. Glow Discharge Processes: Sputtering and Plasma Etching , Brian . Glow Discharge Processes: Sputtering and Plasma Etching . IEEE Xplore Abstract (Authors) - Glow discharge processes . Keywords: Plasma etching, Si etching, Dry etching, SF6 discharge, Glow discharge. 1 Introduction processing such as sputter- and plasma-assisted chemical vapour control of the interaction processes ultimately limit its widespread Glow discharge processes; Sputtering and plasma etching By: Symposium on Plasma Etching and Deposition Hollywood, Fla.) Published: Glow discharge processes : sputtering and plasma etching / Brian Chapman. Glow Discharge Processes: Sputtering and Plasma Etching - Brian . 25 Sep 1980 . Buy Glow Discharge Processes: Sputtering and Plasma Etching by Brian Chapman at best price on Powells.com, available in Hardcover, also Glow Discharge Processes. Sputtering and Plasma Etching

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